

PROCESS FOR FABRICATING A DONOR SUBSTRATE**Abstract**

The invention relates to a process for fabricating a donor substrate, comprising the steps of A: providing a handle substrate, B: providing a target substrate, C: attaching the target
5 substrate to the handle substrate, and D: rectifying, in particular by grinding, the target substrate attached to the handle substrate, so as to form the donor substrate, the process being characterized in that a waiting period of a predetermined duration is observed between step C and step D.

Figure for the Abstract: Figure 1